

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 245810US2TTCRD DIV		SERIAL NO. 10/726,583 New Divisional Application		
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Yoshinori IIDA, et al.				
				FILING DATE Herewith		GROUP Unknown		
U.S. PATENT DOCUMENTS								
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
OC	AA	6,163,061	12/19/2000	Y. IIDA				
OC	AB	6,507,365	01-2003	NAKAMURA et al.				
OC	AC	2001/0005227 A1	06-2001	EGAWA et al.				
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
	AL							
	AM							
	AN							
FOREIGN PATENT DOCUMENTS								
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION			
					YES	NO		
	AO							
	AP							
	AQ							
	AR							
	AS							
	AT							
	AU							
	AV							
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)								
OC	AW	Ishikawa, T. et al., "Low-Cost 320 x 240 Uncooled IRFPA Using Conventional Silicon IC Process," SPIE, Vol. 3698, Apr. 1999, pp. 556-564.						
	AX							
	AY							
	AZ	<input type="checkbox"/> Additional References sheet(s) attached						
Examiner	<i>Olaf Gah</i>		Date Considered 03/24/04					
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								